

Electric forces on a confined ad vacancy island

F. Leroy, A El Barraj, F. Cheynis, P. Muller, S. Curiotto

▶ To cite this version:

F. Leroy, A El Barraj, F. Cheynis, P. Muller, S. Curiotto. Electric forces on a confined ad vacancy island. 2020. hal-02569097v1

HAL Id: hal-02569097 https://hal.science/hal-02569097v1

Preprint submitted on 11 May 2020 (v1), last revised 10 Dec 2020 (v2)

HAL is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers. L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés. 3

Electric forces on a confined *advacancy* island

F. Leroy,^{1,*} A. El Barraj,¹ F. Cheynis,¹ P. Muller,¹ and S. Curiotto¹

¹Aix Marseille Univ, CNRS, CINAM, Marseille, France

(Dated: April 29, 2020)

The passage of an electric current in a material can cause a biased mass transport at its surface. This migration phenomenon is intimately related to the microscopic details of atomic processes of diffusion and attachment/detachment at step edges. Using low energy electron microscopy we have examined in operando under an electric current the migration of Si(111)-1×1 monoatomic advacancy islands confined on Si(111)-7 \times 7 terraces. The islands move opposite to the current direction, with velocity increasing with the radius. We show that the kinetics of attachment/detachment of atoms at step edges and the migration of *ad*atoms on terraces are in competition. The effective valence of Si adatoms is 3.4 ± 0.6 and the kinetic length of attachment-detachment is about 500 nm. The analysis of the islands shape reveals that the electric current biases significantly the kinetic rate of mass transfers at step edges modifying the overall island shape.

• the step edge [1 and 2]. These elementary mechanisms 51 duced by the electric current. 10 may occur simultaneously and their experimental study 52 The experiments were performed in an ultra high vac-11 is all the more difficult that the steps are in competition 53 uum (UHV) setup equipped with a low energy electron 12 as they share a common adatom bath. To study the mass 54 microscope (LEEM III, Elmitec GmbH) [24]. Si(111) 13 transport mechanisms, different experimental strategies 55 substrates (n or p-doped, $\rho=1 \Omega$ cm) were cut into pieces 14 15 16 or on the step displacement velocity when a driving force 58 through the sample via two Mo electrodes clamped to its 17 intervenes [6-8]. In particular the electromigration force, 59 extremities. The samples were degassed in UHV for sev-18 even though it is extremely weak, is known to bias the 60 eral hours at about 1100 K and then flashed above 1500 K ¹⁹ diffusion of mobile *ad* atoms [9–13]. It may also mod-⁶¹ for a few seconds by direct current heating. Advacancy is-20 ify the atomic steps properties such as the local adatom 62 lands are created by Si sublimation in the middle of large 21 equilibrium concentration and/or the kinetic coefficients 63 terraces [25]. The surface evolution under electromigra-22 of attachment-detachment [5, 14, and 15]. These effects 64 tion is studied by LEEM in bright field mode, with an 23 arise since the force felt by atoms depends on their local 65 electron beam energy of 3 eV. To change the advacancy 24 environment that differs at step edges or kink sites. The 66 islands size, Si was deposited in situ by a homemade 25 electromigration force can cause substantial changes in 67 direct current evaporator made of a piece of Si wafer the surface morphology such as step bunching for vici- on clamped between Mo electrodes. 26 nal surfaces [16–19] or shape instabilities of 2D islands 70 27 28 29 ing elementary mechanisms of mass transport at surfaces 72 transition temperature (1133 K). The low temperature $_{30}$ and the impact of electromigration on these mechanisms $_{73}$ 7×7 surface reconstruction nucleates at the step edges 31 appeal for dedicated studies.

32 $_{33}$ mechanisms of mass transport on Si(111) under an elec- $_{76}$ tric current, the 7×7 phase extends onto the terraces 34 tric bias by addressing precisely the boundary conditions 77 (Fig. 1(a)-ii). Since the crystallographic arrangement $_{78}$ to disentangle all the contributions. In that purpose we $_{78}$ of the different 7×7 domains does not necessarily coin-36 37 38 39 40 the island. By adjusting the perimeter of the island and 33 in a metastable supercooled 1×1 state [27]. This effect 41 measuring its drift velocity induced by an electric current $_{84}$ was originally described as a hysteresis of the $1 \times 1 \leftrightarrow$ 42 43 ited by attachment-detachment of atoms at step edges to 86 advacancy island migrates in the direction opposite to 44 a kinetics limited by terrace diffusion. We deduce that s7 the electric current (Fig. 1(a)-iii-iv). During the dis-45 the kinetic length for attachment/detachment is $d \sim 500$ ss placement, the out-of-phase boundaries attached at the

Atomic steps are the most abundant structures at 47 surface is 3.4 ± 0.6 . Importantly our detailed analysis of • surfaces and play a key role in mass transfers. They 48 the stationary shape of the electromigrating advacancy 7 are involved in complex atomic mechanisms such as the 49 islands is consistent with a strong modification of the attachment-detachment of atoms or the diffusion along 50 kinetic rate of attachment/detachment at step edges in-

have been carried out based on the spatio-temporal fluc- $_{56}$ of $15 \times 3 \times 0.5$ mm³, cleaned with acetone and ethanol betuations of the position of isolated/interacting steps [3–5] 57 fore introduction in UHV. An electric current is applied

LEEM images in Fig. 1(a) show the time evolution of [20–23]. The experimental determination of the underly- $_{71}$ the Si(111) surface while crossing the $1 \times 1 \rightarrow 7 \times 7$ phase 74 on the upper terraces [26] and appears as bright lines In this letter we analyze quantitatively the atomic 75 (Fig. 1(a)-i). Upon slow cooling, by decreasing the elechave met two essential conditions: (1) A monoatomic 70 cide, 1×1 out-of-phase boundaries persist at their interheight island where atomic displacements occur at the so sections. Moreover the nucleation of the 7×7 phase is hininterior of a confined 2D space closed by a step edge; and at the lower step edges and on terraces [7], therefore (2) a driving force induced by an electric current to move s2 the advacancy island in the middle of Fig. 1(a)-iii stays we show a transition from a kinetics of mass transfer lim- 35 7×7 phase transition temperature [28]. Interestingly this 46 nm and the effective valence Z* of the Si adatoms at the 39 rear of the island merge from time to time and/or spon-



FIG. 1. (a) Sequence of LEEM images during the $1 \times 1 \rightarrow$ 7×7 phase transition and under electric heating (see complete movie S1 in the supplementary materials). (i) Nucleation of 7×7 surface reconstruction at the step edges on the upper terraces. (ii) Spreading of the 7×7 onto the terraces except in the *ad*vacancy island (black arrow) where the 7×7 nucleation is hindered. (iii) Formation of 1×1 out-of-phase boundaries at the 7×7 domain intersections (white arrows). (iv) Migration of the advacancy island in the $\langle \overline{112} \rangle$ direction, opposite to the electric current. Out-of-phase boundaries merging at the rear side of the island. Electron energy E=3 eV. Scale bar $1\mu m$. (b) Scheme of the surface evolution under slow cooling. (c) ¹²² Time evolution of the displacement of the advacancy island 123 (black square). The steady velocity is 13.1 ± 0.1 nm.s⁻¹ (ve- ¹²⁴ is $1.5 \pm 0.1 \ 10^6 \ \mathrm{nm}^2$ (see bottom inset).

⁹¹ increases up to 13.1 ± 0.1 nm.s⁻¹ and reaches a station-¹³⁰ al. [20] have analyzed the island velocity in the frame-92 ary value when the 7×7 phase significantly covers the 131 work of the linear response theory with weak electromi-93 94 95 $_{96}$ two contributions: The Gibbs-Thompson effect favors the $_{135}$ glecting the *ad* atom flux from the upper terrace (7 × 7), 97 capture of adatoms as the advacancy island curvature is 136 the island drift velocity resulting from these processes is 98 locally the largest one (in absolute). The phase transi- 137 [20]: 99 tion expels the excess atoms of the 1×1 that diffuse to 100 the step edge [29]. The fact that the island area stabi-101 lizes indicates that mass transfers from the exterior are 102 nearly entirely suppressed when the 7×7 covers most of 138 where c_{eq} is the equilibrium surface concentration of mo-103 the surface. This diffusion barrier effect [30] is due to the 139 bile adatoms, $v_{1\times 1}$ is the adatoms velocity on the (1×1) 104 large surface diffusivity of Si adatoms on the 1×1 with 140 terrace and $d = D_{1\times 1}/k$ is the kinetic length of attach-105 respect to the 7×7 (ratio 20, [7]). During its displace- 141 ment/detachment and is defined as the ratio of the sur-106 ment the advacancy island can reach a step edge or a de- 142 face diffusion coefficient $D_{1\times 1}$ to the rate k of adatom $_{107}$ fect that may induce the nucleation of the 7×7 inside the $_{143}$ attachment to the step from the terrace. The fit of the 108 island. To prevent this process from occurring the elec- 144 experimental plots give two key parameters $c_{eq}v_{1\times 1}$ and 109 tric current direction is regularly reversed to change the 145 d. The first term is deduced from the asymptotic veloc-

111 stant temperature $(\pm 1 \text{ K})$. The islands move back and forth over a distance larger than 10 μ m on extended ter-112 113 races without meeting any surface defect or step (Fig. 2(b)). Concomitantly this process allows for the disap-114 pearance of all 1×1 out-of-phase boundaries attached to 115 116 the islands by merging and detachment from the rear 117 side and by removal at the front side. Let us note that 118 a few out-of-phase boundaries have barely no effect on the measured velocity but their removal is important to 120 determine the stationary shape of the *advacancy* island 121 without ambiguity.



FIG. 2. (a) Advacancy island velocity versus radius. The islands electromigrate in the $\langle \overline{112} \rangle$ (black square) and $\langle 11\overline{2} \rangle$ (red square) directions. Fit of the velocity (dotted lines). (b) LEEM images of islands of different sizes electromigrating in the $\langle 11\overline{2} \rangle$ direction (scale bar 5 μ m, see complete movie S2 in the supplementary materials). (c) Scheme of mass transfer process: detachment of atoms (D), biased terrace diffusion (TD) and attachment (A).

To address the mass transport mechanisms that are locity in (a)-i is 5.4 ± 0.3 nm.s⁻¹, see top inset) and the area 125 occurring inside the *advacancy* islands under electromi-¹²⁶ gration we have studied the size-dependence of the island ¹²⁷ velocity in the stationary regime. Figure 2(a) shows that 128 the velocity increases with the island effective radius R⁹⁰ taneously detach. The velocity of the *advacancy* island ¹²⁹ $(R = \sqrt{A}/\pi$ where A is the island area). Pierre-Louis *et* surrounding surface. Simultaneously, after an initial size 132 gration. Considering a kinetics of mass transport by atreduction due to mass transfers with the exterior, the is- 133 tachment (A), detachment (D) and terrace diffusion (TD) land size reaches also a steady state. Mass transfers have 134 inside the 1×1 advacancy island (see Fig. 2(c)), and ne-

$$V_{isl} = c_{eq} v_{1 \times 1} \frac{R}{R+d} \tag{1}$$

110 drift direction by electromigration while keeping a con- 146 ity at large radius $(15\pm1 \text{ nm.s}^{-1})$ and is only related to

3

147 terrace diffusion of the electromigrating adatoms. Con-148 sidering that $c_{eq} \sim 0.2$ ML [29] and correcting the veloc-149 ity with advection [31] (sweeping effect on the adatoms 150 due to the step motion) we get the *ad* atom velocity 151 $v_{1\times 1} = 135 \pm 9$ nm.s⁻¹ on the 1×1 surface reconstruc-152 tion at the phase transition temperature. This velocity derives from the Einstein relation $v_{1\times 1} = \frac{D_{1\times 1}}{k_B T} F$ where k_B is the Boltzmann constant, T the temperature and 155 $F = Z^* e E$ is the electromigration force. Therefore the 156 effective charge Z^* of Si adatoms can be obtained if the 157 diffusion coefficient $D_{1\times 1}$ is known. Hibino *et al.* have **158** found $D_{1\times 1}c_{eq} = 3.0 \ 10^7 \ \text{s}^{-1}$ [7 and 27] at the phase 159 transition temperature. Pang et al. have obtained by 160 different approaches $D_{1\times 1}c_{eq} = 2.0 \pm 0.2 \ 10^7 \ \mathrm{s}^{-1}$ [8] in ¹⁶¹ a slightly higher temperature regime (1163 K). Consid-162 ering an average value for $D_{1\times 1}$ we can deduce the only 163 free parameter, *i.e.* the effective charge of Si adatoms 164 $Z^* = 3.4 \pm 0.6$ (E = 490 V.m⁻¹, atomic area: 0.064 165 nm²). The deduced value of Z^* is larger by one order of ¹⁶⁶ magnitude with earlier reports [32 and 33] except for [34] 167 $(Z^* > 1.3)$. The second term that is deduced from the 168 fit is the kinetic length of attachment/detachment d. We 169 obtain $d_{\langle 11\overline{2}\rangle} = 450 \pm 100$ nm and $d_{\langle \overline{11}2\rangle} = 500 \pm 30$ nm 170 respectively for an island displacement in the $\langle 11\overline{2} \rangle$ and 171 the $\langle \overline{112} \rangle$ directions. These large values are comparable ¹⁷² with previous measurements of the kinetic length of attachment/detachment on the 7×7 [35]. To explain this 174 large kinetic length we can note that the step advance ¹⁷⁵ needs to build 7×7 unit cells. A complex ordering is 176 necessary with potentially concerted events and this pro-177 cess could have a rather low frequency of occurrence [36 178 and 37]. From the evaluation of d we can estimate the 179 rate of attachment/detachment at a step edge per atomic 206 polar coordinates $R(\theta) = R_0 + \rho(\theta)$ (R_0 is the mean ra-180 site $kc_{eq}a = c_{eq}D_{1\times 1}a/d \sim 1.9 \times 10^4 \text{ s}^{-1}$ (a=0.384 nm is 181 the lattice parameter). It is also instructive to estimate 182 the average macroscopic time for *ad* atoms to detach from 183 the front side, cross the island and attach at the rear side. 184 The traveling time across the terrace by diffusion is about $t_d \sim 2R/v_{1\times 1}$ and for a typical island of 1 μ m radius $t_d \sim 200$ where ρ_n and ν_n are the Fourier coefficients ($\nu_n = 0$ for 186 15 s. As a comparative time scale, the delay time for 200 symmetric islands and ρ_1 and ν_1 are not considered be- $_{187}$ an atom to make all attachment/detachment processes $_{210}$ cause they correspond to a simple shape translation). In to cross the island is about $t_{AD} \sim 2d/v_{1\times 1} \sim 6$ to 8 ₂₁₁ Fig. 3(b) are plotted the normalized Fourier coefficients 189 s. This indicates that many events of (re)-attachment- $212 \rho_n/R_0$ as function of the island radius R_0 when the isdetachment occur during this traveling $(kc_{eq}a \times t_{AD} \sim \frac{1}{213})$ and are migrating along the $\langle 11\overline{2} \rangle$ and $\langle \overline{112} \rangle$ directions. 192 10^5 , see Fig.2(c)).

193 194 the stationary regime is measured and depends both on 216 the island radius. ρ_2/R_0 is larger when the island has a 195 196 197 whereas they have a lozenge shape (elongated head and 220 land radius. 198 199 lateral facets) in the opposite direction. If they move 221 Our first insight into the island shape and symmetry $_{200}$ in the $\langle \overline{110} \rangle$ direction the shape is no more symmetric $_{222}$ is based on crystallographic considerations. The step $_{201}$ (Fig. 3(d)). In all cases the shape is elongated in the $_{223}$ edge properties of the 7×7 have a threefold symmetry ²⁰² migration direction. This elongation increases with the ²²⁴ [39 and 40]. However due to symmetry breaking by elec-203 island size and tends to be circular for small sizes (the 225 tromigration, maximum a mirror symmetry can be ex-204 typical crossover is about the attachment-detachment ki- 226 pected. As observed experimentally if the electric cur-205 netic length d). To describe the island shape, we use the 227 rent is along the symmetry axis $\langle 11\overline{2} \rangle$ the shape has a



FIG. 3. (a) LEEM images of advacancy islands electromigrating in the $\langle 11\overline{2} \rangle$ (top) and the $\langle \overline{112} \rangle$ (bottom) directions (scale bar 5 μ m). The shape is respectively a triangle and a lozenge. Unfaulted steps (U_{step}) are shown as dotted lines and faulted steps (F_{step}) as dashed lines [38]. (b) Fourier coefficients of the island shape as function of island radius for both direction. (c) Scheme of the U and F step edge structure. (d) LEEM image of two advacancy islands electromigrating in the $\langle 1\overline{1}0 \rangle$ direction. The shape is asymmetric (scale bar 1 μ m, see complete movie S3 in the supplementary materials).

207 dius), and we apply the Fourier series expansion of $\rho(\theta)$:

$$\rho(\theta) = \sum_{n \ge 2}^{\infty} \rho_n \cos\left(n\theta\right) + \nu_n \sin\left(n\theta\right) \tag{2}$$

²¹⁴ The main term of elongation is the n=2 mode ρ_2/R_0 In addition to velocity, the *advacancy* island shape in 215 and in both cases it increases approximately linearly with the island size and electric current direction. In Fig. 3(a), 217 lozenge shape. The triangular shape of the islands mithe advacancy islands have a facetted front and an overall 218 grating in the $\langle 112 \rangle$ direction is given by a strong n=3 triangular shape when they migrate in the $\langle 11\overline{2} \rangle$ direction ²¹⁹ mode ρ_3/R_0 that is increasing non-linearly with the is-

228 mirror line whereas it is not the case when the electric 273 increases linearly with the island radius R_0 as in the mea-²²⁹ current is along the non-symmetric $\langle \overline{110} \rangle$ direction (Fig. 274 surements, and is along the migration axis if $d_1 + d_3 > 0$. 230 3(d)). As the shape is far from equilibrium the kinetic 275 As $\frac{R_0}{\xi} \sim 0.017 \ll 1$ we can neglect the second order 231 of mass transfers such as the one involved in the attach- 276 contribution in eq. (4). To estimate only the electro- $_{232}$ ment/detachment of atoms at step edges is expected to $_{277}$ bias effect d_1 we use the change of the current direc-233 play a major role.

234 $_{235}$ of advacancy islands driven by an electromigration force $_{280}$ the current direction changes this value by $-d_3$, there-236 on adatoms and considering mass transfers by terrace $_{281}$ fore the kinetic length of electrobias d_1 is obtained by 237 diffusion and attachment/detachment at step edges has $_{282}$ averaging both shape elongation $\frac{\rho_2}{R_0}$ in the $\langle 11\overline{2} \rangle$ and 238 been calculated [20, 31, and 41]. The elongation of the 239 advacancy islands is perpendicular to the migration di-²⁴⁰ rection considering isotropic surface properties. This ²⁸⁵ is thermally activated, we extract the activation energy ²⁴¹ shape can be qualitatively interpreted as resulting from a maps can be quantatively interpreted as resulting from a 242 mass flux towards the migration axis. Indeed in presence 286 $E_1 = k_B T \ln \left(1 + \frac{d_1}{d}\right) = 1.2 \ 10^{-2}$ eV. This electrobias ef-243 of a slow kinetics of attachment, the adatoms make sev- 287 fect on the step edge is much larger than on adatoms ²⁴⁴ eral trials before attaching to the step and have a residual ²⁸⁸ ($E = Fa/2 \sim 3.2 \ 10^{-7}$ eV). This result could be related 245 drift towards the migration axis. In a steady state the 289 to an intrinsic change of step properties induced by the 246 local curvature of the island is modified to compensate 290 current but it may also arise from a change of kink den-247 this mass flux by a capillary effect. Quantitatively the 291 sity at step edges. Indeed it has been shown [43] that an ²⁴⁸ change of shape involves the n = 2 mode as ρ_2/R_0 ratio ²⁹² electric current in the $\langle 11\overline{2} \rangle$ direction along a step and as-(elongation) and reads ([20] for $d \ll R_0$):

$$\frac{\rho_2}{R_0} = -\frac{1}{12\Gamma} \frac{R_0^2}{\xi^2} d < 0 \tag{3}$$

²⁵⁰ where $\Gamma = \frac{a^2 \tilde{\beta}}{k_B T}$ is the capillary length (Gibbs-Thomson ²⁹⁸ trobias effect on steps or kinks has already been found $_{\tt 251}$ effect), $\tilde{\beta}$ is the step edge stiffness and ξ is a character-²⁵² istic length associated with the electromigration force: $253 \xi = \frac{k_B T}{F} = 58 \ \mu m$. This result is opposite to the ex-²⁵⁴ perimental shape since the elongation of the *advacancy* 255 islands is along the displacement direction $\left(\frac{\rho_2}{R_0} > 0\right)$ 256 whatever this direction is. Therefore we conclude that 257 the anisotropy of the surface properties cannot solely ex-258 plain it. We propose that the electric current modifies 259 not only the adatom displacement but also the atomic 260 step properties. As a minimum model, the electric cur- $_{\tt 261}$ rent breaks the threefold symmetry of the kinetic rate of ²⁶² attachment-detachment at the step edges [42]. To study 263 this effect we expand the kinetic length d as a Fourier 264 series $d = \overline{d} + \sum_{n} d_{n} \cos(n\theta)$ where \overline{d} is the mean kinetic **265** length of attachment/detachment and d_n are the Fourier 266 coefficients for a symmetric shape. The main Fourier 267 term acting as an electrobias, *i.e.* changing the kinetics 268 of attachment-detachment at the step edge, is expected 269 to be d_1 (without electrobias only d_{3n} exists by sym-²⁷⁰ metry). Expanding linearly the shape of the *advacancy* ³¹⁷ of anisotropy, non-linearities and high density of *ad*atoms 271 island with this electrobias effect we obtain:

$$\frac{\rho_2}{R_0} = -\frac{1}{12\Gamma} \left[\frac{R_0^2}{\xi^2} \left(\overline{d} + \frac{d_2}{2} \right) - 2\frac{R_0}{\xi} \left(d_1 + d_3 \right) \right]$$
(4)

²⁷² The shape elongation $\frac{\rho_2}{R_0}$ shows a new contribution that ³²² the ANR grant HOLOLEEM (ANR-15-CE09-0012).

 $_{278}$ tion in the experiment. Assuming that d_3 is not signifi-In the framework of a continuous step model, the shape 279 cantly affected by the electrobias effect, the inversion of 283 the $\langle\overline{11}2\rangle$ directions. We estimate that $d_1\sim 68\pm 10$ 284 nm ($\Gamma = 1$ nm [8]) and considering that this contribution ²⁹³ cending the kinks favors the formation of an atomically ²⁹⁴ straight step edge. Therefore considering that the kinet-²⁹⁵ ics of mass transfers at step edges is mediated by kinks ²⁹⁶ then the rate of attachment/detachment could be indeed ²⁹⁷ strongly modified by the electric current. Such an elec-299 on metal surfaces [5 and 14] but not on semiconductors ³⁰⁰ even though it has been suspected to occur [44].

> In conclusion we have shown on Si(111) surface that 301 $_{\tt 302}$ a monoatomic advacancy island in the 1×1 high tem-303 perature phase and surrounded by the 7×7 low temper- $_{\tt 304}$ ature phase can be stabilized. This regime allows keep-305 ing the 2D island in a confined state in terms of atomic 306 exchanges. Then under the influence of an electric cur-307 rent, the island is moving. The analysis of the velocity $_{\tt 308}$ and shape of the island as function of its radius show 309 that (i) Si adatoms migration on the terrace is biased 310 and they have an effective valence Z^* of 3.4 ± 0.6 (ii) the 311 kinetic of attachment/detachment of atoms at the step 312 edges is very slow and we evaluate the kinetic length as $_{313} \sim 500$ nm. (iii) An electrobias effect on the kinetics of 314 attachment/detachment at step edges elongates the is-315 land shape in the direction of the electric current. We 316 believe that a complete modeling including all the effects ³¹⁸ would be necessary to describe precisely the island shape.

> We are grateful to Olivier Pierre-Louis for instructive 320 discussions and Plateform PLANETE (CNano PACA) 321 for technical support. This work has been supported by

leroy@cinam.univ-mrs.fr

¹ Hyeong-Chai Jeong and Ellen D Williams. Surf. Sci. Rep.,

- 34(6-8):171-294, 1999. 325
- Chaouqi Misbah, Olivier Pierre-Louis, and Yukio Saito. 374 326 Reviews of Modern Physics, 82(1):981-1040, 2010. 327
- N. C. Bartelt, J. L. Goldberg, T. L. Einstein, Ellen D. 376 328 Williams, J. C. Hevraud, and J. J. Métois. Physical Review 377 329
- B, 48(20):15453-15456, 1993. 330 378 DB Dougherty, I Lyubinetsky, ED Williams, M Con- 379 331
- stantin, C Dasgupta, and S Das Sarma. Physical Review 380 332 Letters, 89(13):136102, 2002. 333 381
- O. Bondarchuk, W. G. Cullen, M. Degawa, E. D. Williams, 382 334
- T. Bole, and P. J. Rous. Physical Review Letters, 383 335 99(20):206801, 2007. 384 336
- K. Thurmer, J.E. Reutt-Robey, E.D. Williams, M. Uwaha, 385 337 A. Emundts, and H.P. Bonzel. Physical Review Letters, 386 338
- 87(18):186102, 2001. 339 H. Hibino, C.-W. Hu, T. Ogino, and I. S. T. Tsong. Phys- 388 340
- *ical Review B*, 63(24):245402, 2001. 341 8 A. B. Pang, K. L. Man, M. S. Altman, T. J. Stase-
- 390 342 vich, F. Szalma, and T. L. Einstein. Physical Review B, 391
- 343 77(11):115424, 2008. 344
- 9 H. B. Huntington and A. R. Grone. J. Phys. Chem. Solids, 393 345 20:76, 1961. 346
- 10I. A. Blech. J. Appl. Phys., 47(4):1203-1208, 1976. 347
- 11 A. H. Verbruggen. IBM J. Res. Dev., 32(1):93-98, 1988. 348
- 12P. S. Ho and T. Kwok. Rep. Prog. Phys., 52(3):301-348, 349 1989. 350
- 13H. Yasunaga and A. Natori. Surf. Sci. Rep., 15(6-7):205- 399 351 280, 1992. 352
- 14C. Tao, W. G. Cullen, and E. D. Williams. Science,353 328(5979):736-740, 2010. 354
- 15Kirk H. Bevan, Hong Guo, Ellen D. Williams, and Zhenyu 403 355 Zhang. Physical Review B, 81(23):235416, 2010. 356
- 16 A.V. Latvshev, A.L. Aseev, A.B. Krasilnikov, and S.I. 405 357 Stenin. Surface Science, 213(1):157-169, 1989. 358 406
- Y Homma, RJ McClelland, and H Hibino, Jpn. J. Appl. 407 359 Phys., 29(12):L2254-L2256, 1990. 360 408
- F. Leroy, P. Müller, J. J. Metois, and O. Pierre-Louis. 409 361 Phus. Rev. B, 76(4), 2007. 410 362
- 19F. Leroy, D. Karashanova, M. Dufay, J. M. Debierre, 411 363 T. Frisch, J. J. Metois, and P. Müller. Surf. Sci., 412 364 603(3):507-512, 2009. 413 365
- 20O. Pierre-Louis and T. L. Einstein. Phys. Rev. B, 414 366 62(20):13697-13706, 2000.367
- Philipp Kuhn, Joachim Krug, Frank Hausser, and Axel 416 368 Voigt. Physical Review Letters, 94(16):166105, 2005. 369
- 22A. Kumar, D. Dasgupta, C. Dimitrakopoulos, and 418 370
- D. Maroudas. Appl. Phys. Lett., 108(19):193109, 2016. 371
- A. Kumar, D. Dasgupta, and D. Maroudas. Physical Re- 420 372

view Applied, 8(1):014035, 2017. 373

375

419

- 24F. Cheynis, F. Leroy, A. Ranguis, B. Detailleur, P. Bindzi, C. Veit, W. Bon, and P. Müller. Review of Scientific Instruments, 85:043705, 2014.
- 25Yoshikazu Homma, Hiroki Hibino, Toshio Ogino, and Noriyuki Aizawa. Physical Review B, 55(16):R10237-R10240, 1997.
- 26 N Osakabe, Y Tanishiro, K Yagi, and G Honjo. Surface Science, 109:359-366, 1981.
- 27H. Hibino, Y. Watanabe, C.-W. Hu, and I. S. T. Tsong. Physical Review B, 72(24):245424, 2005.
- 28 C.-W. Hu, H. Hibino, T. Ogino, and I. S. T. Tsong. Surface Science, 487:191–200, 2001.
- 29Y.-N. Yang and E. D. Williams. Physical Review Letters, 72(12):1862-1865, 1994. 387
- 30 H. Hibino, C.-W. Hu, T. Ogino, and I. S. T. Tsong. Physical Review B, 64(24):245401, 2001. 389
 - 31 Frank Haußer, Philipp Kuhn, Joachim Krug, and Axel Voigt. Physical Review E, 75(4):046210, 2007.
- 32Daniel Kandel and Effhimios Kaxiras. Physical Review 392 Letters, 76(7):1114-1117, 1996.
- 33 E.S. Fu, D.J. Liu, M.D. Johnson, J.D. Weeks, and E.D. 394 Williams. Surface Science, 385:259-269, 1997. 395
- 34Andrés Saùl, Jean-Jacques Métois, and Alain Ranguis. 396 Physical Review B, 65(7):075409, 2002. 397
- 35 W. F. Chung and M. S. Altman. Physical Review B, 398 66(7):075338, 2002.
- 36 Wataru Shimada, Tomoshige Sato, and Hiroshi Tochihara. 400 Physical Review B, 94(3):035402, 2016. 401
- 37 Ing-Shouh Hwang, Mon-Shu Ho, and Tien T Tsong. Phys-402 ical Review Letters, 83(1):120, 1999.
- 38 H. Tochihara, W. Shimada, M. Itoh, H. Tanaka, M. Uda-404 gawa, and I. Sumita. Physical Review B, 45(19):11332-11335. 1992.
 - 39 Noriko Akutsu and Yasuhiro Akutsu. Journal of Physics: Condensed Matter, 11(35):6635-6652, 1999.
 - 40 Noriko Akutsu. Surface Science, 630:109-115, December 2014.
 - 41Stefano Curiotto, Frederic Leroy, Pierre Müller, Fabien Cheynis, Ali El-Barraj, Michail Michailov, and Bogdan Ranguelov. J. Cryst. Growth, 520:42-45, 2019.
- 42Nobuo Suga, Junya Kimpara, Nan-Jian Wu, Hitoshi Yasunaga, and Akiko Natori. Japanese Journal of Applied 415 *Physics*, 39(Part 1, No. 7B):4412–4416, July 2000.
- 43S. Yoshida, T. Sekiguchi, and K. M. Itoh. Applied Physics 417 Letters, 87(3):031903, 2005.
 - Mon-Shu Ho, Ing-Shouh Hwang, and Tien T. Tsong. Physical Review Letters, 84(25):5792-5795, 2000.